

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of:

Galburt *et al.*

Appl. No.: 10/632,798

Filed: August 4, 2003

For: **Method to Increase Throughput in  
a Dual Substrate Stage Double  
Exposure Lithography System** (as  
amended)

Confirmation No.: 7458

Art Unit: 2851

Examiner: H. Nguyen

Atty. Docket: 1857.1710001

**Amendment and Reply Under 37 C.F.R. § 1.111**

Commissioner for Patents  
Mail Stop Non-Fee Amendment  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the final Office Action dated **August 13, 2004**, Applicants submit the following Amendment and Remarks.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.